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#### APPLICATION FOR UTILITY PATENT

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# **Optical Component Plastic Deformation Control Process**

### RELATED APPLICATION

This application is a Continuation-in-Part of U.S. Application No. 09/667,186, filed on September 21, 2000, the entire teachings of which are incorporated herein by this reference.

#### BACKGROUND OF THE INVENTION

Component alignment is of critical importance in microoptical systems and especially semiconductor and/or MOEMS (microoptical electromechanical systems) optical system manufacturing. The basic nature of light requires that light generating, transmitting, and modifying components must be positioned accurately with respect to one another, especially in the context of free-space-interconnect optical systems, in order to function properly and effectively. Scales characteristic of optical semiconductor and MOEMS technologies can necessitate micron to sub-micron alignment accuracy.

Consider the specific example of coupling light from a semiconductor diode laser, such as a pump or transmitter laser, to single mode fiber. Only the power that is coupled into the fiber core is usable, and the coupling efficiency is highly dependent on accurate alignment between the laser output facet and the core; inaccurate alignment can result in partial or complete loss of signal transmission through the optical system. Moreover, if polarizationmaintaining fiber is used, there is an added need to rotationally align the fiber relative to the laser to maintain the single polarization characteristic of the output signal.

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Other more general examples include optical amplification, receiving and/or processing systems. Some alignment is typically required between an optical signal source, such as the fiber endface, and a detector. In more complex systems including tunable filters, for example, alignment is required not only to preserve signal power, dynamic range, but also to yield high quality systems through the suppression of undesirable optical modes within and without the systems.

In the example of a tunable filter system, light, typically provided by fiber, is supplied to an optical train, including a tunable filter, such as Fabry-Perot (FP) tunable filter. The launch characteristics of the light into the FP filter cavity determine the side mode suppression ratio (SMSR) of the system. This ratio, in part, dictates the quality of the system. If light is launched into the filter at the wrong position or with the wrong spot size, higher order modes are excited in the filter, degrading the system's SMSR. Typically, filter train alignment is employed to extract the highest possible SMSR.

Generally, there are two types of alignment strategies: active and passive. Typically, in passive alignment of the optical components, registration or alignment features are fabricated directly on the optical components, such as the optical elements or element mounting structures, and/or the platform on which the components are to be mounted. The components are then mounted and bonded directly to the platform using the alignment features. In active alignment, an optical signal is transmitted through the components and detected. The alignment is performed based on the transmission characteristics to enable the highest possible performance level for the system.

In the context of commercial volume manufacturing, selection between active and passive alignment, or some mix of the two, is determined based on the quality of part needed. Lower cost, lower performance devices are typically manufactured with entirely passive alignment strategies, whereas the manufacture of high performance devices typically involves at least some active alignment.

Another dimension to the alignment challenge concerns how optical component alignment is effected. Solder joining and laser welding are two common mounting

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techniques. Solder attachment of optical elements can be accomplished by performing alignment with a molten solder joint between the element to be aligned and the platform or substrate to which it is being attached. The solder is then solidified to "lock-in" the alignment. In some cases, an intentional offset is added to the alignment position prior to solder solidification to compensate for subsequent alignment shifts due to solidification shrinkage of the solder. In the case of laser welding, the fiber, for example, is held in a clip that is then aligned to the semiconductor laser and welded in place. The fiber may then also be further welded to the clip to yield alignment along other axes. Secondary welds are often employed to compensate for alignment shifts due to the weld itself, but as with solder systems, absolute compensation is difficult. Other alignment strategies for optical systems rely on the plastic deformation of the optical component after its installation so that an optical element of the component is brought into an improved alignment with respect to the surrounding optical system.

#### **SUMMARY OF THE INVENTION**

Plastic deformation-based alignment strategies rely on first understanding the stress, strain/yield-point characteristics of the optical component coupled with the ability to apply the force necessary to achieve alignment in view of these characteristics. Ideally, the optical component would be moved into a proper alignment and then simply released. The optical components, however, have elasticity. Thus, it is typically required, during the plastic deformation, to deform the optical component "beyond" the desired alignment position by a carefully controlled distance, such that when the optical component is released, it elastically returns to the desired alignment position.

The present invention is directed to an alignment process that addresses mechanical compliance in the alignment system and/or optical system during the plastic deformation of optical components of the optical system. This mechanical compliance arises from the fact that there is typically flexing in the alignment system between the encoders and the part of the alignment system that actually engages the optical component. Moreover, it is typically desirable to perform the alignment on a partially completed optical system, which has been

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installed into a hermetic package, typically prior to lid sealing. Thus, the hermetic package is typically clamped in a chuck. There is typically no way to detect compliance between the optical bench of the optical system and the package and possibly, an intervening thermoelectric cooler. This prevents simple process of finding the desired location then deforming the component until it is consistent with that desired position. Thus, the present invention is directed to a plastic deformation system that addresses this "mechanical slop" that is endemic to the underlying mechanical system.

In general, according to one aspect, the invention features a process for aligning an optical component by plastic deformation. The process comprises finding a desired position of an optical axis of the optical component relative to a rest position of the optical axis of the optical component. Then, a deformation force is exerted, which is greater than a yield force of the optical component to thereby plastically deform the optical component in a direction of the desired position.

According to the preferred embodiment, the step of determining the rest position is performed after the step of finding the desired position to account for any plastic deformation and/or work hardening that are induced during the process of finding the desired position.

Moreover, preferably, to avoid backlash problems in the mechanical system, the optical component is not plastically deformed beyond the desired position with respect to a previous rest position. Also, in the preferred embodiment, to track whether or not the alignment process is converging, an active alignment signal is monitored during the deformation process. If the level of this active alignment signal falls substantially below a level of the peak active alignment signal, which was determined during the desire position search, as the optical component is moved through the desired position during the process of deformation, the new desired position is determined relative to a new rest position and the alignment process is restarted.

According to one application, the process is used to align a fiber endface, which is supported on a deformable structure. This alignment can be performed based upon a level of back reflection as an active alignment signal.

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According to another application, an optical signal is transmitted through an optical element of the optical component and spectrally analyzed. The optical component is then aligned to improve side mode suppression, for example.

According to still another application, an optical signal is generated by energizing an active device on the optical bench. Mounting structure for an optical fiber is then deformed based upon the amount of optical signal that is coupled into the optical fiber.

The above and other features of the invention including various novel details of construction and combinations of parts, and other advantages, will now be more particularly described with reference to the accompanying drawings and pointed out in the claims. It will be understood that the particular method and device embodying the invention are shown by way of illustration and not as a limitation of the invention. The principles and features of this invention may be employed in various and numerous embodiments without departing from the scope of the invention.

#### **BRIEF DESCRIPTION OF THE DRAWINGS**

In the accompanying drawings, reference characters refer to the same parts throughout the different views. The drawings are not necessarily to scale; emphasis has instead been placed upon illustrating the principles of the invention. Of the drawings:

Figs. 1A and 1B are perspective views of an alignment system aligning an optical fiber endface to a semiconductor laser chip to illustrate an exemplary application of the present invention;

Fig. 2 is plot in a Cartesian coordinate system illustrating an alignment search process according to the present invention utilizing active alignment;

Fig. 3 is a multi-dimensional plot illustrating a plastic deformation alignment process according to the present invention incorporating active alignment;

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Fig. 4 illustrates the plastic deformation process during an intermediate stage of the alignment, according to the present invention;

Fig. 5 illustrates the plastic deformation process in a final stage of the process, according to the present invention; and

Fig. 6 illustrates the plastic deformation process during an intermediate stage in which the alignment process compensates for an earlier error in plastic deformation, according to the present invention.

## DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

Fig. 1 shows a semiconductor laser system, which is used herein to illustrate an application of the present invention.

Specifically, the system comprises a package 10. In the illustrated example, a butterfly package is used in which leads 14 extend laterally from the package. In other implementations, the invention can also be applied to DIP packages where the leads 14 extend orthogonally from the floor 16 of the package 10.

In the illustrated cooled laser system, a thermo-electric cooler 100 is installed on the floor 16 of the package 10. These coolers are typically driven in response to the temperature within the package, detected by thermistor 112 for example, to maintain a temperature-stable operating environment for the semiconductor laser chip 114.

A bench or submount 102 is secured to the cooler 100. In the preferred embodiment, the bench 102 is constructed from a mechanically and temperature stable substance, such as aluminum nitride, silicon, silicon-metal composite, silicon oxide, or beryllium oxide in various implementations.

Semiconductor laser chip 114 is connected to the bench 102. The illustrated example uses an edge-emitting, stripe semiconductor chip. In more detail, the chip is bonded to a substrate 111 to form a chip hybrid. This chip hybrid is then preferably solder-bonded to the

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bench 102. A monitoring diode 116 is installed on the bench 102 behind a back facet of the chip 114. Specifically, the monitoring diode 116 is installed on a pedestal structure 118, which is similarly solder-bonded to the bench 102.

An optical fiber pigtail 106 enters the package 10 through a fiber feedthrough in which a ferrule 108 is installed. The endface of the fiber pigtail is secured to the bench 102 in proximity to the front facet of the semiconductor chip 114 along the laser stripe-defined medial line 108.

A deformable fiber mounting structure 104 is used so that the endface 107 is held in a stable but adjustable relationship to the semiconductor laser front facet.

In the illustrated implementation, jaws 210, 212 of an alignment system engage the fiber mounting structure 104. In part of the alignment process, these jaws 210, 212 mechanically engage and plastically deform this mounting structure 104 so that the endface is aligned to receive the light emitted from the laser chip 114.

Fig. 1B illustrates the relationship between the fiber endface 107 and the exit facet of the chip 114. This endface 107 is centered on the chip's ridge center line 108 so that coupling efficiency is maximized, *i.e.*, as much light as possible that is generated by the chip is coupled to be transmitted by the fiber pigtail 106. This is achieved by plastically deforming the mounting structure 104.

For the purposes of the following discussion, a Cartesian coordinate system x, y is defined between the fiber endface 107 and the emission area of the chip 114.

Further, the present discussion is specific to aligning a fiber endface to a chip emission pattern. The alignment strategy, however is generally applicable to applications where the optical component comprises a lens, or some other optical component such as a tunable filter or reflective element, that is mounted to the mounting structure and alignment is relative to an optical axis of a surrounding optical train.

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Fig. 2 illustrates a pre-alignment exemplary relationship between the fiber endface 107 and the emission pattern 310 for the chip 114 in the x, y plane.

The relationship between the endface and the emission pattern 310 is typically not initially known. A search process is started in which the endface 107 is moved through the x, y plane to find the emission pattern. In the illustrated example, a circle search algorithm is implemented in which the endface is moved or dithered in circles, repeatedly, while monitoring the coupled light to find the relative direction of the emission 310. The center of the search pattern is then stepped in the direction of the apparent pattern.

More specifically, the optical axis of endface 107 is initially at position p(start). It is then moved in circle 210. Based on the signal measurements during the movement, the general direction of the emission 310 is determined and the search process advanced so that the endface is scanned in circle 212.

The circle scan and step process is repeated until the circle scan is centered on the emission center, see circle 214. Thus, the emission 310 is located. At this location, a force vector 312, magnitude and direction, is recorded. This provides the force and direction of that force that is required to move the endface from a rest position to the position of best coupling efficiency.

When the mounting structure is released after this initial emission search, it may not return to the p(start) position. This typically occurs if the search process resulted in plastic deformation and/or work hardening. As illustrated, when released, the endface snaps-back to position p0.

Fig. 3 is multidimensional plot in which the coupling efficiency figure of merit (FOM) is additionally plotted. Typically, when the fiber endface optical axis is at point p0, the coupling efficiency as illustrated by the distance  $l_0$  is very low.

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In order to improve the alignment, the force vector 312 is exerted by the jaws 210 and 212 on the mounting structure 104 to improve the alignment between the endface107 and the chip emission 310.

In the illustrated example, the force vector 312 is not coincident with a line between the center of the endface 107 and the emission pattern 310. This may be because the mounting structure 104 is more compliant to the X-axis as opposed to the Y-axis deformation.

When the force vector 312 is applied to the mounting structure 104, the endface 107 moves from point p0 to point p1. At point p1, the alignment is improved, as illustrated by the coupling efficiency plot.

Continued deformation, pushes the endface to point p2, where the alignment is ideal. However, because of the elasticity, the mounting structure 104 must be further deformed to point p3 to plastically or permanently deform the alignment structure 104. Plastic deformation is initiated when the force vector exceeds a yield force of the structure 104.

When point p3 is reached, the jaws 210, 212 begin to release force, allowing the mounting structure 104 to return to its new rest position p5. As the force is removed, the FOM is analyzed. This can be an important step in the analysis to ensure convergence. Specifically, as force is removed, the FOM is monitored to ensure that the endface passes over the best alignment position, or laser emission center where the coupling efficiency peaks. In the event that it does not, *i.e.*, the coupled optical energy does not reach the level detected in the initial search within tolerances, a new search process should be initiated.

Fig. 4 shows the new relationship between the fiber endface 107 and the emission pattern 310 after the plastic deformation step illustrated in Fig. 3. Specifically, the coupling efficiency is improved by the fact that they have been closer together and specifically distance  $l_2$ . This coupling efficiency, however, is still inadequate, in illustrated example.

Therefore, a second plastic deformation step is performed is illustrated in Fig. 5 where the current yield force of the structure is again exceeded. Force vector 314 is applied and the

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fiber endface 107 moves from the new rest position p5 through position p6 showing proper alignment to point p7. Then, when the jaws of the alignment system allow the mounting structure to return to a rest position, it returns to new rest position at point p7 because of this second plastic deformation operation.

The final alignment position is illustrated in Fig. 5. While alignment is not perfect, the coupling efficiency is very close to the peak. In one application, this alignment accuracy would be adequate. Typically, for conventional high power pump applications, the endface 107 must be aligned to within 200 nanometers of the emission's center.

Generally, care is taken to avoid plastically deforming the endface between the target position. This avoids backlash in alignment system.

As illustrated in Fig. 6, according to an aspect of the invention, the coupling efficiency figure of merit is monitored while the mounting structure is allowed to return to a rest position. If this new rest position, as illustrated by point p10 exhibits poor coupling efficiency because the plastic deformation is not converging to the ideal alignment position p6, a new rest position is determined for p10 and then a new force vector calculated to deform the mounting structure in the direction of point p6.

While this invention has been particularly shown and described with references to preferred embodiments thereof, it will be understood by those skilled in the art that various changes in form and details may be made therein without departing from the scope of the invention encompassed by the appended claims.